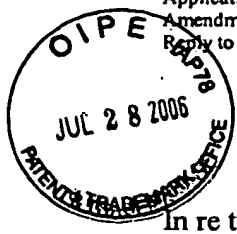


TFW AF



Application No. 10/734,704
Amendment Dated July 24, 2006
Reply to Final Office Action of May 23, 2006

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of

REDEKER et al.

Application No.: 10/734,704

Filed: December 12, 2003

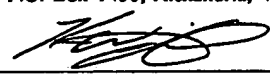
For: METHOD AND APPARATUS FOR
SEMICONDUCTOR WAFER
PLANARIZATION

)
) Examiner: Edwards, Laura Estelle
)
) Art Unit: 1734
)
) Docket No.: LAM2P461
)
) Date: July 24, 2006

OKAY
TO
ENTER
the
8/14/06

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on July 24, 2006.

Signed: 
Kenneth D. Wright

REQUEST FOR RECONSIDERATION

Mail Stop: AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This Request for Reconsideration is submitted in response to the Final Office Action dated May 23, 2006, and within the two month period extending from the date of the Final Office Action to July 24, 2006. Please note that July 23, 2006, is a Sunday. Therefore, the two month after-final period extends to Monday, July 24, 2006. Please enter the following remarks.

The Claims are reflected in the listing of claims which begins on page 2 of this Request for Reconsideration.

Remarks/Arguments begin on page 7 of this Request for Reconsideration.